

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L5	2	JP-09208324\$	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/06 17:03
L7	28	(matsuura near Takashi).in. and silicon near nitride	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/06 17:11
L8	1	(matsuura near Takashi).in. and silicon near nitride and tungsten	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/06 17:13
L9	5	(yamakawa near akira).in. and silicon near nitride and tungsten	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/06 17:15
L14	3	"5158914"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/06 17:37
S1	1	10/527513	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:10
S2	23	"5369065"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:10

S3	15	"5424256"	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:13
S4	201	(silicon near nitride or Si3N4) same metal same powder same (MgO or SiO or sinter\$4 same aids)	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:18
S5	0	S4 and sputter\$4 same target	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:19
S6	13	S4 and sputter\$4	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:19
S7	2	wo-2004024452\$	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:30
S8	12	(silicon near nitride or Si3N4) same metal same powder same (MgO or SiO or sinter\$4 same aids)and HIP	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:37
S9	14	"5160508"	US_PGPUB; USPAT; USOOR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 10:52

S11	2	JP-2000154064\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 11:08
S12	2	JP-2000164064\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 11:12
S13	2	JP-11139877\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 11:13
S14	2	JP-11139874\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 11:17
S15	100	(silicon near nitride or Si3N4) same (tungsten or W) same powder same (MgO or SiO or sinter\$4 same aids)	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 15:52
S16	0	JP-5864268\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 16:14
S17	2	JP-58064268\$	US_PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/10/03 16:14

10/6/2008 6:36:23 PM

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